

Notice of References Cited	Application/Control No. 09/943,886	Applicant(s)/Patent Under Reexamination WU ET AL.	
	Examiner Clemence Han	Art Unit 2665	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,842,455	01-2005	Heuer, Volkmar	370/393
	B	US-5,257,261	10-1993	Parruck et al.	370/522
	C	US-5,923,653	07-1999	Denton, I. Claude	370/375
	D	US-6,014,708	01-2000	Klish, Cypryan T.	709/232
	E	US-6,765,933	07-2004	Michel et al.	370/539
	F	US-6,917,630	07-2005	Russell et al.	370/532
	G	US-2002/0012141	01-2002	Traverso, Giovanni	359/124
	H	US-2002/0001308	01-2002	Heuer, Volkmar	370/386
	I	US-2003/0007513	01-2003	Barker et al.	370/476
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 200131820 A2	05-2001	World Intellect	KLAUSMEIER et al.	H04J 03/00
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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